

<b>FORM PTO-1449</b>  <b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b>  (use several sheets if necessary)	SERIAL NO. 09/933,218	ATTORNEY DOCKET NO. SJO920000160US1
	FILING DATE 08/20/2001	GROUP ART UNIT 2627
	APPLICANT(S): Jeffrey S. Lille	

**REFERENCE DESIGNATION**
**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION	
						YES	NO
<i>Chen</i>	A1	JP 08287534 A	11/01/1996	Japan	G11B009-00		X

**NON-PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)

<b>EXAMINER</b> <i>Chen Tzeng</i>	<b>DATE CONSIDERED</b> <i>03/15/2007</i>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).

FORM PTO-1449  <b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b>  (use several sheets if necessary)	SERIAL NO. <u>09/933,218</u> Not yet assigned	ATTORNEY DOCKET NO. SJO920000160US1
	FILING DATE August 20, 2001	GROUP ART UNIT <u>2652</u>
	APPLICANT(S): Jeffrey S. Lille	

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09/933218  
08/20/01

## REFERENCE DESIGNATION

## U.S. PATENT DOCUMENTS

EXAMINE R INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLAS S	FILING DATE
<i>Chen</i>	A1	5,959,801	09/28/99	Gillis et al.	360/75	10/22/97
	A2	5,856,967	01/05/99	Mamin et al.	369/126	08/27/97
	A3	5,764,432	06/09/98	Kasahara	360/75	01/24/96
	A4	5,745,319	04/28/98	Takekado et al.	360/78.05	04/27/95
<i>Chen</i>	A5	4,814,908	03/21/89	Schmitz	360/77.02	12/03/86

## FOREIGN PATENT DOCUMENTS

EXAMINE R INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION	
						YES	NO
<i>Chen</i>	A6	JP4-157685	05/29/92	Japan	<del>G41B24/24</del>		X
	A7	JP62-3476	01/09/87	Japan	<del>G41B24/24</del>		X
	A8	JP59-203272	11/17/84	Japan	<del>G41B24/48</del>		X
<i>Chen</i>	A9	EP 242 597	10/28/87	Europe	<del>G41B21/20</del>	X	

## NON-PATENT DOCUMENTS

EXAMINE R INITIAL		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)
<i>Chen</i>	A10	K. H. Stokes and R. B. Watrous, "Magnetic Head with Piezoelectric Positioning", Vol. 16 No. 5, October 1973, p. 1429.
<i>Chen</i>	A11	G. Elsner, H. Hinkel and E. Prinz, "Magnetic Head with Retractable R/W Element", Vol. 27 No. 7B, December 1984, pp. 4573-4574.

EXAMINER <i>Chen Tarp</i>	DATE CONSIDERED <u>03/26/04</u>
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<i>Chen</i>	A12	Bruce D.S. Chou, Change-Nan Chen and Jin-Shown Shie, "Micromachining on (111)-Oriented Silicon", Sensors and Actuators 75 (1999) 271-277.
<i>Chen</i>	A13	John H. Comtois, M. Adrian Michalick and Carol Craig Barron, "Electrothermal Actuators Fabricated in Four-level Planarized Surface Micromachined Polycrystalline Silicon", Sensors and Actuators A 70 (1998) 23-31.

EXAMINER <i>Chen Tzeng</i>	DATE CONSIDERED <i>03/26/04</i>
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